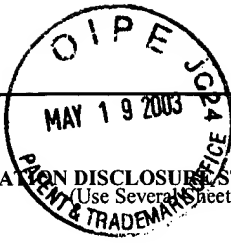


FORM PTO-1449  
(Modified)U.S. Department of Commerce  
Patent and Trademark Office

Attorney Docket No.: SLM-05800

Serial No.: 09/832,738

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use Several Sheets If Necessary)

(37 CFR § 1.98(b))

Applicant: Robert W. Corrigan et al.

Filing Date: April 10, 2001

Group Art Unit: 2643

## U.S. PATENT DOCUMENTS

Examiner Initials		Serial / Patent Number	Issue Date	Applicant / Patentee	Class	Subclass	Filing Date
CN	AA	5,661,592	8/26/97	Bornstein et al.	359	291	6/7/95
CN	AB	6,172,796	1/9/01	Kowarz et al.	359	290	12/18/98
CN	AC	6,181,458	1/30/01	Brazas, Jr. et al	359	290	12/18/98
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## FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS

		Document Number	Publication Date	Country / Patent Office	Class	Subclass	Translation	
							Yes	No
	AP							
	AQ							
	AR							
	AS							
	AT							

## OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)

	AU	
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Examiner:

Date Considered:

4/9/04

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FORM PTO-1449  
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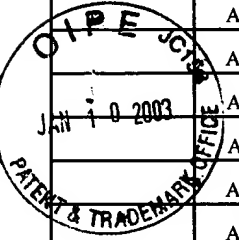
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**RECEIVED****JAN 13 2003****Technology Center 2600****FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS**

		Document Number	Publication Date	Country / Patent Office	Class	Subclass	Translation	
							Yes	No
<b>CU</b>	AP	WO 99/07146	02/11/99	PCT	H04N	7/16		X
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	AR							
	AS							
	AT							

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(37 CFR § 1.98(b))

Filing Date: April 10, 2001

Group Art Unit: 2643

## U.S. PATENT DOCUMENTS

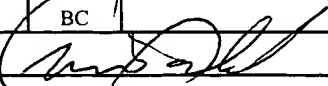
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CA	AA	4,011,009	03/08/77	Lama et al.	350	162 R	05/27/75
	AB	5,995,303	11/30/99	Honguh et al.	359	708	09/29/95
	AC	5,999,319	12/07/99	Castracane	359	573	04/29/98
	AD	6,071,652	06/06/00	Feldman et al.	430	5	03/20/98
	AE	6,122,299	09/19/00	DeMars et al.	372	20	12/31/97
	AF	6,252,697 B1	06/26/01	Hawkins et al.	359	290	12/18/98
	AG	6,268,952 B1	07/31/01	Godil et al.	359	291	07/14/99
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CA	AP	EP 0 322 714 A2	07/05/89	EP	G02B	5/30		X
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CA	AU	"Micromachined Opto/Electro/Mechanical Systems," Electronic Systems, NASA Tech Briefs, March 1997, pgs.50 & 52.					
CA	AV	David M. Burns et al., "Development of Microelectromechanical Variable Blaze Gratings," Sensors and Actuators A 64 (1998), pgs 7-15.					
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	BC						

Examiner: 

Date Considered: 4/8/04

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FORM PTO-1449  
(Modified)U.S. Department of Commerce  
Patent and Trademark Office

Attorney Docket No.: S11A-05800

Serial No.: 09/832,738

INFORMATION DISCLOSURE STATEMENT BY APPLICANT  
(Include all pertinent references and prior art sheets if necessary)

Applicant: Robert W. Corrigan et al.

(37 CFR § 1.98(b))

Filing Date: April 10, 2001

Group Art Unit: 2643

## U.S. PATENT DOCUMENTS

Examiner Initials		Serial / Patent Number	Issue Date	Applicant / Patentee	Class	Subclass	Filing Date
CN	AA	5,704,700	01/06/98	Kappel et al.	353	31	07/24/95
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Attorney Docket No.: SLM-05800

Serial No.: 09/832,738

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Group Art Unit: 2643

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CW	AA	5,311,360	05/10/94	Bloom et al.	359	572	04/28/92
	AB	5,629,801	05/13/97	Staker et al.	359	572	06/07/95
	AC	5,757,536	05/26/98	Ricco et al.	359	224	08/30/95
	AD	5,764,280	06/09/98	Bloom et al.	348	53	03/20/97
	AE	5,808,797	09/15/98	Bloom et al.	359	572	04/26/96
	AF	5,982,553	11/09/99	Bloom et al.	359	627	03/20/97
	AG	6,215,579 B1	04/10/01	Bloom et al.	359	298	06/24/98
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## OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)

CW	AP	R.W. Corrigan et al., "Calibration of a Scanned Linear Grating Light-Valve, Projection System for E-Cinema Applications", Silicon Light Machines, SID'99, San Jose, CA, 27 pgs, 1999.						
CW	AQ	R.W. Corrigan et al., "Calibration of a Scanned Linear Grating Light-Valve, Projection System", Silicon Light Machines, San Jose, CA, 4 pgs, May 18, 1999.						
CW	AR	"Introduction to Cryptography", <a href="http://www.ssh.fi/tech/crpto/into.html">http://www.ssh.fi/tech/crpto/into.html</a> , 35 pgs, June 21, 1999.						
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# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

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Title of  
Invention

METHOD, SYSTEM AND DISPLAY APPARATUS FOR  
ENCRYPTED CINEMA

Application Number: 09/832738

Confirmation Number: 3462

First Named Applicant: Robert Corrigan

Attorney Docket Number:

Search string: ( 4257053 or 4561011 or 5216278 or 5320709  
or 5552635 or 5832148 or 5841929 or 6012336  
or 6096656 or 20020131228 or 20020195418 or  
20020196492 ).pn.



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That no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of the information disclosure statement.

## US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
ca	1	4257053	1981-03-17	Gilbreath			
	2	4561011	1985-12-24	Kohara et al.			
	3	5216278	1993-06-01	Lin et al.			
	4	5320709	1994-06-14	Bowden et al.			
	5	5552635	1996-09-03	Kim et al.			
	6	5832148	1998-11-03	Yariv			
	7	5841929	1998-11-24	Komatsu et al.			
	8	6012336	2000-01-11	Eaton et al.			

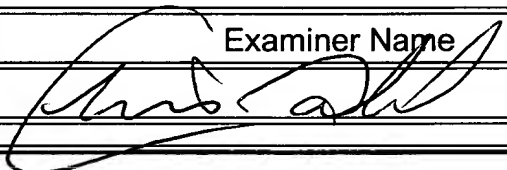
CA	9	6096656	2000-08-01	Matzke et al.
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## US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
CA	1	20020131228	2002-09-19	Potter	A1		
	2	20020195418	2002-12-26	Kowarz et al.	A1		
	3	20020196492	2002-12-26	Trisnadi et al.	A1		

## Signature

	Examiner Name	Date
		4/8/04

## ELECTRONIC INFORMATION DISCLOSURE STATEMENT

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METHOD, SYSTEM, AND DISPLAY APPARATUS FOR ENCRYPTED CINEMA

Application Number: 09/832738

\*09/832738\*

Confirmation Number: 3462

First Named Applicant: Robert Corrigan

Attorney Docket Number:

Search string: ( 5963788 or 6356689 or 5319668 or 6565222 or 4963012 or 20020112746 or 20020131230 or 20010019454 ).pn.

## US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
CN	1	5963788	1999-10-05	Barron et al.		438	48
	2	6356689	2002-03-12	Greywall	B1	385	52
	3	5319668	1994-06-07	Luecke		372	107
	4	6565222	2003-05-20	Ishii et al.	B1	359	883
	5	4963012	1990-10-16	Tracy et al.		350	641

## US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
CN	1	20020112746	2002-08-22	DeYoung et al.	A1	134	36
CN	2	20020131230	2002-09-19	Potter	A1	361	277
CN	3	20010019454	2001-09-06	Tadic-Galeb et al.	A1	359	649

## Remarks

Note: Remarks are not for responding to an office action.

Non US Patent and Publication references shall be filed under a separate paper transmittal. The current electronic filing contains part 16 out of a total of 16 electronic filings.

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Examiner Name	Date
<i>Chris [Signature]</i>	4/8/04

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Search string: ( 5031144 or 5185823 or 5206829 or 6249381  
or 6282213 or 6313901 or 6346430 or 6418152  
or 6479811 or 6569717 or 20020135708 or  
20020176151 or 20030056078 ).pn.



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## US Patent Documents

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init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
CA	1	5031144	1991-07-09	Persky			
	2	5185823	1993-02-09	Kaku et al.			
	3	5206829	1993-04-27	Thakoor et al.			
	4	6249381	2001-06-19	Suganuma	B1		
	5	6282213	2001-08-28	Gutin et al.	B1		
	6	6313901	2001-11-06	Cacharelis	B1		
	7	6346430	2002-02-12	Raj et al.	B1		
	8	6418152	2002-07-09	Davis	B1		

<i>CV</i>	9	6479811	2002-11-12	Kruschwitz et al.	B1
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Note: Applicant is not required to submit a paper copy of cited US Published Applications

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<i>CV</i>	3	20030056078	2003-03-20	Johansson et al.	A1		

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











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Date Considered:

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Attorney Docket No.: SLM-05800

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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Filing Date: April 10, 2001

Group Art Unit: 2643

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		Document Number	Publication Date	Country / Patent Office	Class	Subclass	Translation	
							Yes	No
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Applicants: Robert W. Corrigan et al

(37 CFR § 1.98(b))

Filing Date: April 10, 2001

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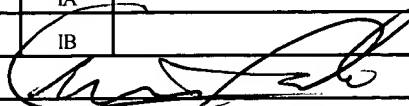
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